



## Progress in MEMS/NEMS Devices

Guest Editor:

**Prof. Per Ohlckers**

University of South-Eastern  
Norway, Raveien 215, No-3199  
Horten, Norway

Deadline for manuscript  
submissions:

**closed (31 October 2019)**

### Message from the Guest Editor

Ever since they first emerged as a spinoff from integrated circuit technology, MEMS/NEMS devices have experienced progress that has not only been remarkable but is still rapidly progressing.

Worldwide, excellent research activities on MEMS/NEMS devices are steadily contributing to the progress of the state-of-the-art, and in this Special Issue, we will highlight work of excellence in the field.

Potential topics include, but are not limited to, the keywords listed below:

- MEMS devices
- NEMS devices
- micro- and nanosystems
- Microsensors
- Microactuators
- Silicon micromachining
- Bulk micromachining
- Surface micromachining
- Front-end electronics
- Monolithic integration

Welcome to contribute!





an Open Access Journal by MDPI

## Editor-in-Chief

**Prof. Dr. Flavio Canavero**

Department of Electronics and  
Telecommunications,  
Politecnico di Torino, 10129  
Torino, Italy

## Message from the Editor-in-Chief

*Electronics* is a multidisciplinary journal designed to appeal to a diverse audience of research scientists, practitioners, and developers in academia and industry. The journal is devoted to fast publication of latest technological breakthroughs, cutting-edge developments, and timely reviews of current and emerging technologies related to the broad field of electronics. Experimental and theoretical results are published as regular peer-reviewed articles or as articles within Special Issues guest-edited by leading experts in selected topics of interest.

## Author Benefits

**Open Access:** free for readers, with article processing charges (APC) paid by authors or their institutions.

**High Visibility:** indexed within Scopus, SCIE (Web of Science), CAPlus / SciFinder, Inspec, and other databases.

**Journal Rank:** JCR - Q2 (*Physics, Applied*) / CiteScore - Q2 (*Control and Systems Engineering*)

## Contact Us

---

Electronics Editorial Office  
MDPI, Grosspeteranlage 5  
4052 Basel, Switzerland

Tel: +41 61 683 77 34  
[www.mdpi.com](http://www.mdpi.com)

[mdpi.com/journal/electronics](http://mdpi.com/journal/electronics)  
[electronics@mdpi.com](mailto:electronics@mdpi.com)  
[X@electronicsMDPI](https://x.com/electronicsMDPI)